

In view of the preceding amendments and remarks, Applicant respectfully submits that the claim as amended are allowable over the cited prior art reference, and allowance at Examiner's earliest convenience is hereby respectfully requested. In the event that the Examiner believes a teleconference would facilitate prosecution, Applicant respectfully requests that Examiner contact the undersigned.

Respectfully submitted,



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**VERSION WITH MARKINGS TO SHOW CHANGES MADE:**

**IN THE SPECIFICATION:**

**please insert the following on Page 1, line 2 before “Background of the  
Invention”**

Statement of Related Application

This application is related to patent application serial number 09/998,336  
entitled “Method for Fabricating GaN Field Emitter Arrays” and patent application  
serial number 09/998,294 entitled “Improved Nanotip Structure Formed from  
Dislocations in a Material”, both filed on November 29, 2001 and assigned to the same  
Assignee.

**IN THE CLAIMS**

In the Claims, please delete claim 9-13.